



UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE
 United States Patent and Trademark Office
 Address: COMMISSIONER FOR PATENTS
 P.O. Box 1450
 Alexandria, Virginia 22313-1450
 www.uspto.gov



Bib Data Sheet

CONFIRMATION NO. 7228

SERIAL NUMBER 10/804,430	FILING DATE 03/19/2004 RULE	CLASS 216	GROUP ART UNIT 1765	ATTORNEY DOCKET NO. LMRX-P032/P1205
-----------------------------	---------------------------------------	--------------	------------------------	---

APPLICANTS

Jisoo Kim, Pleasanton, CA;
 Binet Worsham, Mountain View, CA;
 Bi-Ming Yen, Fremont, CA; Peter K. Loewenhardt, Pleasanton, CA;

** CONTINUING DATA ***** NONE LV

** FOREIGN APPLICATIONS ***** NONE LV

IF REQUIRED, FOREIGN FILING LICENSE GRANTED
 ** 05/30/2004

Foreign Priority claimed 35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance	STATE OR COUNTRY CA	SHEETS DRAWING 13	TOTAL CLAIMS 39	INDEPENDENT CLAIMS 2
---	---	---------------------------	-------------------------	-----------------------	----------------------------

Verified and Acknowledged
 Examiner's Signature: *[Signature]* Initials: *LV*

ADDRESS
 32986
 IPSP, P.C.
 P.O. BOX 700640
 SAN JOSE, CA
 95170-0640

TITLE
 Methods for the optimization of substrate etching in a plasma processing system

FILING FEE RECEIVED 1112	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue)
------------------------------------	---	--